



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Application of: Tetsuo AOYAMA et al.

Confirmation No: 1070

Application No.: 10/826,319

Art Unit: 1751

Filed: April 19, 2004

Examiner:

For: **AQUEOUS FLUORIDE COMPOSITIONS
FOR CLEANING SEMICONDUCTOR
DEVICES**

Atty Docket No.: 060937-0186-US

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

U.S. Patent and Trademark Office
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Mail Stop AMENDMENT
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Arlington, Virginia 22202

Sir:

In accordance with the duty of disclosure provisions of 37 C.F.R. §1.56, there is hereby provided certain information which the Examiner may consider material to the examination of the subject U.S. patent application. It is requested that the Examiner make this information of record if it is deemed material to the examination of the application.

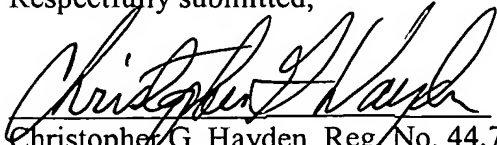
Enclosed with this Information Disclosure Statement is a list of all patents, publications, applications, or other information submitted for consideration by the Office. The references were cited in a co-pending foreign application; a copy of the International Search Report is enclosed. None of the references listed are submitted, however they can be provided upon request.

No fee is believed due for this submission, since this Information Disclosure Statement is being submitted before an Office Action. Should any fees be required, however, please charge the required fees to Morgan, Lewis & Bockius LLP Deposit Account No. 50-0310

Respectfully submitted,

November 12, 2004

By:


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LIST OF REFERENCES CITED BY APPLICANT (Use several sheets if necessary)	ATTY DOCKET NO.	APPLICATION NO
	060937-0186-US	10/826,319
	APPLICANT Tetsuo AOYAMA et al.	
	FILING DATE	GROUP
	April 19, 2004	1751

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A01	6,508,887	01/2003	Park et al.			
	A02	2002/0066465 A1	06/2002	Gotoh et al.			
	A03	2003/0082912 A1	05/2003	Kezuka et al.			
	A04	2004/0038254 A1	02/2004	Muramatsu et al.			
	A05						
	A06						
	A07						
	A08						
	A09						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	B01	1 277 830	01/2003	EP				
	B02	1 035 446	09/2000	EP				
	B03	03/104900	12/2003	PCT				
	B04							
	B05							

OTHER REFERENCES *(Including Author, Title, Date, Pertinent Pages, Etc.)*

	C01	
	C02	
	C03	

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.